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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Docket Number: 10901/36

Application Number 10/069,086

Filing Date
July 8, 2002

Examiner
To be assigned

Art Unit 2877

Invention Title

REFLECTOMETER AND METHOD FOR MANUFACTURING A REFLECTOMETER

Inventor(s)
WEIDMANN et al.

Commissioner for Patents Washington D.C. 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

Date: 45 Nay 28, 2003

Reg. No. 22,490

Signature:

Richard L. Mayer

Ps, N.2. 42,154

In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the references listed on the attached modified PTO Form No. 1449 to the attention of the Examiner. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

2. A copy of the publication listed on the modified PTO form 1449 is enclosed, except as otherwise indicated.

3. It is believed that no fees are due in connection with this supplemental Information Disclosure Statement. However, should any fees be due the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Dated: February 28, 2003 By:

Richard L. Mayer (Reg. No.

deliaid L. Mayer (Reg. No. 12,

KENYON & KENYON

One Broadway

New York, N.Y. 10004

(212) 425-7200 (telephone)

(212) 425-5288 (facsimile)

U.S. DEPARTMENT OF COMMERCE & TRADE PATENT AND TRADEMARK OFFICE SUPPLEMENTAL INFORMATION Docket Number: **DISCLOSURE STATEMENT** 10901/36 Application Number Filing Date Examiner Art Unit 10/069,086 July 8, 2002 To be assigned 2877 Invention Title Inventor(s) REFLECTOMETER AND METHOD FOR WEIDMANN et al. MANUFACTURING A REFLECTOMETER

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Date: HSNAY 78,7003
Signature: LLL. Mayer

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Chitton a ten man

KENYON & KENYON One Broadway

New York, N.Y. 10004

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| STATEMENT BY APPLICANT | APPLICANT J. Weidmann et al. | | | |
| | FILING DATE July 8, 2002 | GROUP 2877 | | |

U. S. PATENT DOCUMENTS

| EXAMINER INITIAL | PATENT NUMBER | PATENT DATE | NAME | CLASS | SUBCLASS | FILING DATE |
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FOREIGN PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT | | | | | TRANSLA | ATION |
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OTHER DOCUMENTS

| EXAMINER | | | | |
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| * Listed in International Search Report (copy not provided, copy provided by International Searching Authority) | | | | |

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